



May 9, 2024

TO: THE DISTRICT BOARD OF TRUSTEES OF VALENCIA COLLEGE

FROM: DR. KATHLEEN PLINSKE
President

RE: ROBOTICS AND SEMICONDUCTOR CLEAN ROOM EXPANSION

On January 31, 2024, the State of Florida Department of Education, awarded Valencia College a \$4,345,454 grant from the Workforce Development Capitalization Incentive Program (CAP Grant), to assist in the development of an A.S. Degree in Semiconductor Engineering Technology and two CTE dual enrollment certificates: Semiconductor Clean Room Operations, and Laser and Photonics. The program is to be located at the Center for Accelerated Training and the Center for Industry and Technology facilities on the Osceola Campus.

In accordance with the authority granted under F.A.C 6A-14.0734 (2)(h) and Florida Statute 287.057, on April 22, 2024, Valencia College issued Single Source (SS) 2024-29, Robotics/Semiconductor Clean Room Expansion to notify the public of the Intent to Single Source.

The Wafer Simulated Production Line Equipment are sole source products designed, assembled, and manufactured exclusively by Roots Education Co., LLC. The single source procurement is required for the purpose of efficiency in standardization of equipment. The total cost of the Wafer Simulated Production Line Equipment is \$1,366,248.

RECOMMENDED ACTION:

The President recommends that the District Board of Trustees of Valencia College authorize the College to award Roots Education, Co., LLC. The Single Source procurement of the Wafer Simulated Production Line Equipment in the amount of \$1,366,248.



President